



PATENTS

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT : WENSYANG HSU, et al.
SERIAL NO. : 10/603,291 GROUP : 2878
FILED : June 25, 2003
TITLE : Method for Manufacturing a Combined Solid Immersion Lens (SIL) and Submicron Aperture, and Device thereof

INFORMATION DISCLOSURE STATEMENT

MAIL STOP: NON-FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R :

Applicants wish to bring to the attention of the Patent Examiner the references listed on the enclosed Form PTO-1449 and attached thereto. The references and articles are discussed on pages 2 and 3 of the specification.

Since this Information Disclosure Statement is being filed prior to a first Office Action, it is believed that no fee is due. However, if it is determined that a fee is due, the Commissioner is hereby authorized to charge our deposit account number 03-2468, without further authorization.

It is respectfully requested that this Information Disclosure Statement be considered and placed into the application file.

Respectfully submitted,

WENSYANG HSU, et al.

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Enclosures: PTO-form 1449, six (6) prior art references.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents and Trademarks, P.O. Box 1450, Alexandria, VA on March 18, 2004.

Maria Guastella

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO. :
BA-22855

SERIAL NO. 10/603,291

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	6,335,522B1	Jan. 2002	Asimada, et al.			
	AB	6,154,326	Nov. 2000	Ueyanagi, et al.			
	AC	6,055,220	Nov. 2000	Mamin, et al.			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

AR		Mansfield and Kino, "Solid immersion microscope" Appl. Phys. Lett. 57 (1990) pp. 2615, 2616
AS		Terris, Mamin, and Rugar "Near-field optical data storage using a solid immersion lens" Appl. Phys. Lett. 65 (1994) pp. 388-390
AT		Lane, "Fabrication of Sub-micron Optical Apertures by an Over-Electroplating Method" ISOM (2001) pp. 252-253

EXAMINER

DATE CONSIDERED